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Rhonda Grant

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Docket: 0756-1551

#24 Election
10-8-97
M.R.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT Application of:)
Shunpei YAMAZAKI et al.)
Serial No. 08/691,434) Art Unit: 1107
Filed: August 2, 1996) Examiner: Wilczewski
For: METHOD OF FABRICATING)
SEMICONDUCTOR DEVICES)
AND APPARATUS FOR)
PROCESSING A)
SEMICONDUCTOR) Date: September 15, 1997



RESPONSE TO ELECTION REQUIREMENT

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

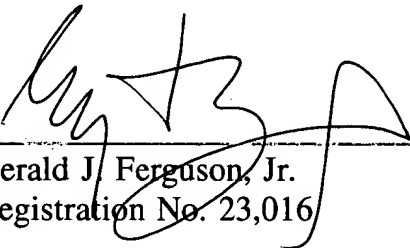
Sir:

In response to the election requirement in the Office Action of July 16, 1997, Applicants hereby elect without traverse the second species of the claimed invention as recited in claims 16, 17, 18, 19, 20, 24, and 25 in which the semiconductor processing apparatus includes a vacuum chamber, an ion introducing apparatus, and a laser processing apparatus and the second sub-species as recited in claims 56-61 in which the semiconductor processing apparatus includes a vacuum chamber, an ion introducing apparatus, and a laser

processing apparatus and in which the rectangular-shaped laser beam has a width greater than the width of the "substantially" square substrate.

Examination on the merits is requested.

Respectfully submitted,



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